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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

pplication of: VAN BERKEL

Application No.:

09/910,269

Examiner:

OCT 1 9 200%

Date Filed:

July 19, 2001

Group:

TC 1706

For:

THIN-CHANNEL ELECTRODE ELECTROSPRAY EMITTER

CERTIFICATE UNDER 37 CFR 1.8(a)

I hereby certify that this correspondence is being deposited with the U.S. Postal Service as First Class mail in an envelope addressed to the Commissioner for Patents, Washington, D.C. 20231, on

Reg. No. 46,803

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents Washington, DC 20231

Sir:

In accordance with the duty of disclosure under 37 C.F.R. § 1.56, Applicant hereby notifies the U.S. Patent and Trademark Office of the documents which are listed on the attached Form PTO-1449 which the Examiner may deem relevant to patentability of the claims of the above-identified application.

The submission of the listed documents are not intended as an admission that any listed document constitutes prior art against the claims of the present application. Applicant does not waive any right to take any action that would be appropriate to antedate or otherwise remove any listed document as a competent

reference against the claims of the present application.

Applicant respectfully requests that the listed documents be considered by the Examiner and be made of record in the present application and that an initialed copy of Form PTO-1449 be returned in accordance with MPEP §609.

Although no fee is believed due, the Commissioner is hereby authorized to charge any fees which may be required by submission of these papers to Deposit Account No. 50-0951.

Respectfully submitted,

AKERMAN SENTÆRFITT & EIDSON, P.A.

Dated: 10/12/0]

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Docket No. 6321-200

OCT 1 5 2001 Form PTO-1449 U.S. DEPARTMENT OF COMMERCE
PATENT AND TRADEMARX OFFICE 6321-200 INFORMATION CONSCLOSURE STATEMENT ATTY. DOCKET NO. APPLICATION NO. 09/910,269 (Rev. 2-88) APPLICANT VAN BERKEL BY APPLICANT (Use several sheets if necessary) FILING DATE 7/19/01 GROUP U.S. PATENT DOCUMENTS EXAMINER'S INITIAL DOCUMENT NUMBER 4,861,988 8/29/89 Henion et al. 5,869,832 2/9/99 Wang et al. 5,879,949 3/9/99 Cole et al. 5,975,426 11/2/99 Myers FOREIGN PATENT DOCUMENTS DATE COUNTRY CLASS

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	DATE CONSIDERED

EXAMINER: Initial if a citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.